

PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 3742**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Atsuo KONDO et al.

Group Art Unit: 3742

Application No.: 10/581,748

Examiner: Q. VAN

Filed: June 6, 2006

Docket No.: 128342

For: PLASMA GENERATING ELECTRODE, ITS MANUFACTURING METHOD, AND
PLASMA REACTOR

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

OK TO ENTER: /Q.V./

Sir:

In reply to the March 30, 2009 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.